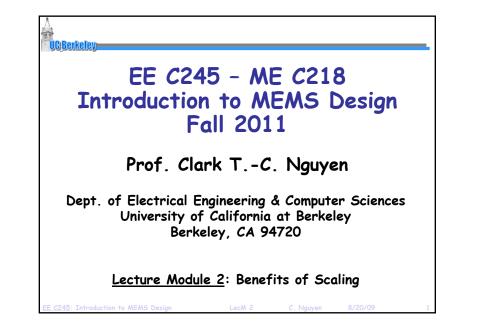
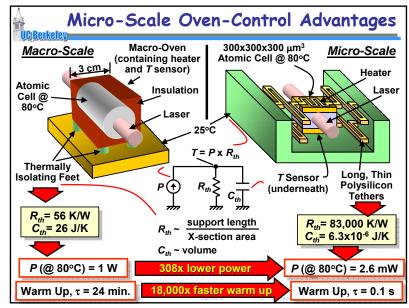
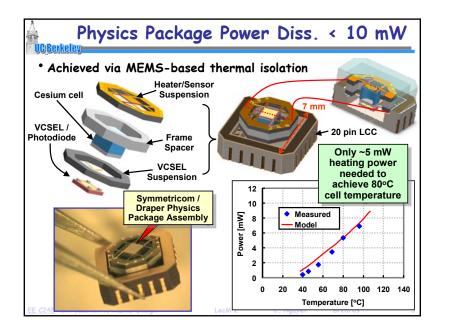
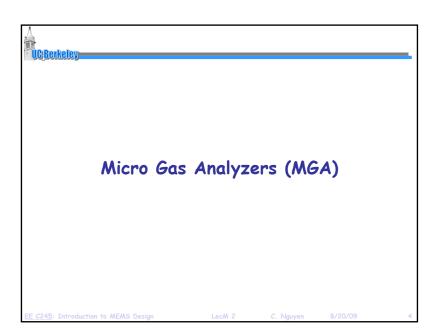
<u>EE C245/ME C218</u>: Introduction to MEMS <u>Lecture 4m</u>: Benefits of Scaling III









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